



501.36931CX2

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): T. Iwasaki, et al.

Appln. No. 09/255,856

Filed: February 23, 1999

For: SEMICONDUCTOR DEVICE WITH LAYERED INTERCONNECT  
STRUCTURE

Group: 2813

Examiner: S. Smoot

RECEIVED  
FEB -5 2004  
1C 2800 MAIL ROOM

AMENDMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

January 29, 2004

Sir:

In response to the Office Action mailed July 29, 2003, please amend the  
above-identified application as listed below and as set forth on the following pages:

Amendments to the Claims; and

Remarks are included following the amendments.